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<b>TRANSMITTAL LETTER</b> <b>(General - Patent Pending)</b>	Docket No. 113184-114
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In Re Application of: **Hiroshi, et al.**

Application No. 10/563,630	Filing Date January 6, 2006	Examiner Unknown	Customer No. 24573	Group Art Unit Unknown	Confirmation No. Unknown
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Title: **NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR PREPARATION THEREOF**

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

- Preliminary Amendment (4 pgs.);
- Replacement Drawings (2 sheets); and
- Return Receipt Postcard

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **02-1818** as described below.
  - ☐ Charge the amount of \_\_\_\_\_
  - ☒ Credit any overpayment.
  - ☒ Charge any additional fee required.
- ☐ Payment by credit card. Form PTO-2038 is attached.

**WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**

Signature

Dated: **February 27, 2006**

**Thomas C. Basso**  
**Reg. No. 46,541**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on	
February 27, 2006	
(Date)	
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